

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	DEPOSITION OF CARBON- AND TRANSITION METAL-CONTAINING THIN FILMS							
Application Number :	10/642426							
Confirmation Number:	9896							
First Named Applicant:	Kari Harkonen							
Attorney Docket Number:	11429/19:2							
Art Unit:	1762							
Examiner:	Mr. Bret P. Chen							
Search string:	(20050037557).pn							
<p><u>Certification:</u> This Information Disclosure Statement was submitted under the following conditions, which satisfies the requirement under 37 CFR 1.97(e). The filer certified:</p> <p>That no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement.</p>								
US Published Applications								
<p>Note: Applicant is not required to submit a paper copy of cited US Published Applications</p>								
init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass	
	1	20050037557	2005-02-17	Doczy et al.	A1	438	197	
Signature								
Examiner Name				Date				